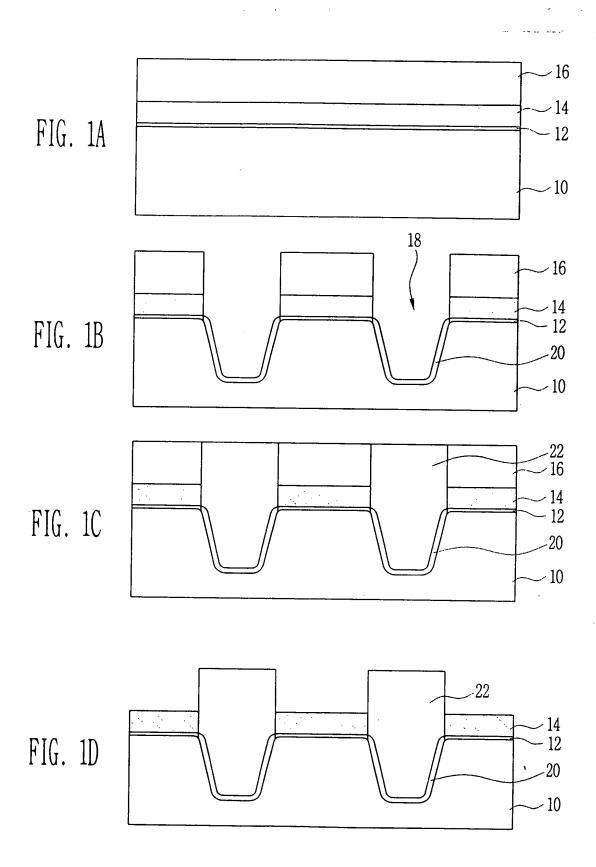
Attny Docket No. 29936/39474

Title: "Method of Manufacturing a Semiconductor Device"

Inventor: Dong et al.

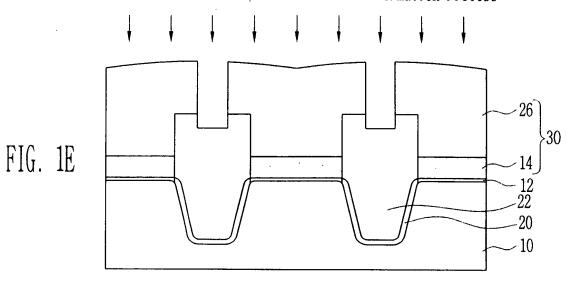
FIGS 1A-1D Sheet 1 of 3

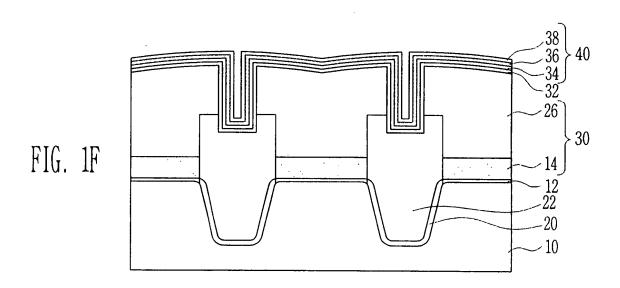


Attny Docket No. 29936/39474
Title: "Method of Manufacturing a Semiconductor Device"

Inventor: Dong et al. FIGS 1E-1F Sheet 2 of 3

Nitrification Process, Dielectric Film Formation Process





Attny Docket No. 29936/39474

Title: "Method of Manufacturing a Semiconductor Device"
Inventor: Dong et al.
FIGS 1G-2
Sheet 3 of 3

